

INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Complete if Known</i>	
				Application Number	09/513,998
				Filing Date	February 23, 2000
				First Named Inventor	Richard J. Helferich
				Group Art Unit	2684
				Examiner Name	Tan H. Trinh
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Sheet	1	of	1	Attorney Docket Number	
0101-140					

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)			
	A	KR	00164369	I	B1	Samsung Electronics Co., Ltd.	September 11, 1998 ✓ AB
	B	JP	06318899	I	A	Dokomo Eng KK Tanaka Masanori	November 15, 1994 ✓ AB

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code.

*Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁵Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.